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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of: Ranish et al.

Group Art Unit: 3742

Application No: 10/773,650 Confirmation No: 7636

Examiner: Shawntina T. Fuqua

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Title: Thermally Matched Support Ring for Substrate Processing Chamber

October 13, 2004

San Francisco, California

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents P.O. Box 1450 . Alexandria, VA 22313-1450 VIA FACSIMILE (703) 872-9306

Examiner Fuqua:

This communication is in response to the Office Communication mailed on June 15, 2004, and is being filed within four months thereof with a request for a one month extension of time.

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